

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 50277-2430		SERIAL NO. Not Yet Assigned	
				APPLICANT: Jay ROSSITER, et al.			
				FILING DATE: Herewith		GROUP: Not Yet Assigned	
U.S. PATENT DOCUMENTS							
Exam. Initial*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number	Kind Code ² (If known)				
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Exam. Initial*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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SA		EP	0 274 406	A2	Computer X, Inc.	07/13/1988		
SA		EP	0 803 808	A2	Sun Microsystems, Inc.	10/29/1997		

Substitute for Form 1449A/PTO (Modified) (use as many sheets as necessary)	Attorney Docket No.: 50277-2430	Application Number: Not Yet Assigned
	First Named Inventor: Jay ROSSITER, et al.	
Filing Date: Herewith		

OTHER ART – NO PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	Translation ²
SA		Achutha Raman R et al., "PARDISC: A Cost Effective Model for Parallel and Distributed Computing," August 1996, pp. 451-456, IEEE Catalog Number: 96TB100074.	
SA		Chaudhuri, Surajit, et al., "An Overview of Data Warehousing and OLAP Technology," March 1997, pp. 65-74, ACM Press, Vol. 26, Issue 1.	
SA		Hyuck Yoo, et al., "Operating System Performance and Large Servers," Proceedings of the 6 th Workshop on ACM SIGOPS European workshop: Matching operating systems to application needs, 1994, pg. 166-171.	

Examiner Signature	<i>Shahid Akbar</i>	Date Considered	9/18/01
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